

Fig. 1a (prior art)

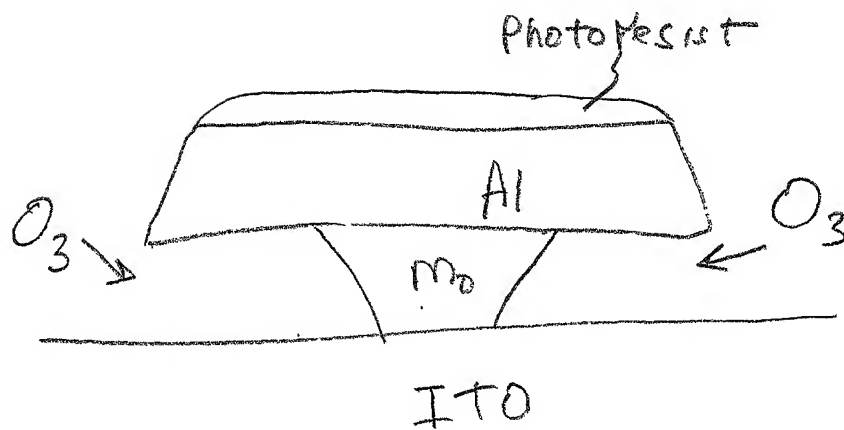


Fig. 1b (prior art)

Etch rate of Materials by O3 water (85ppm, pH3.3)

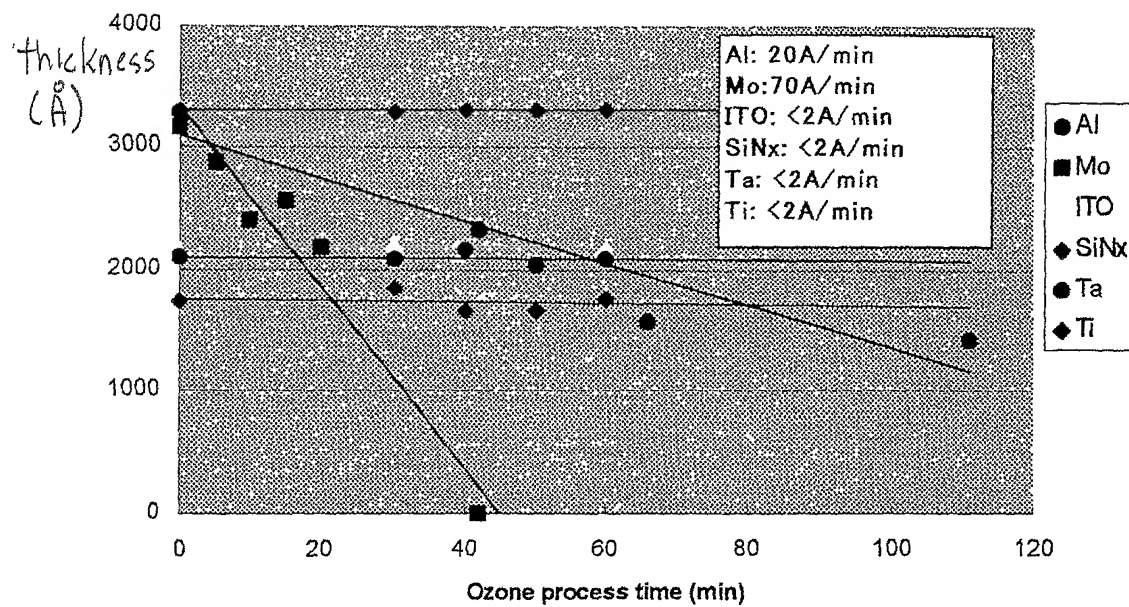


Fig. 2

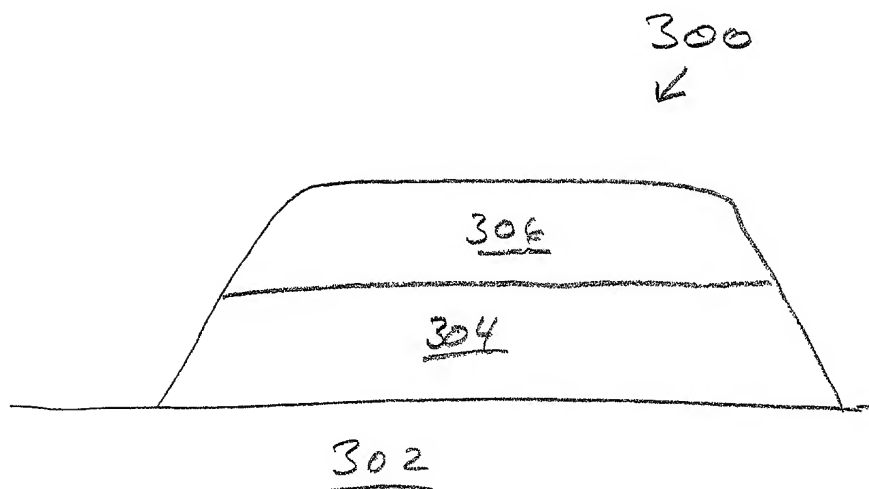
[illegible]

Fig. 3a

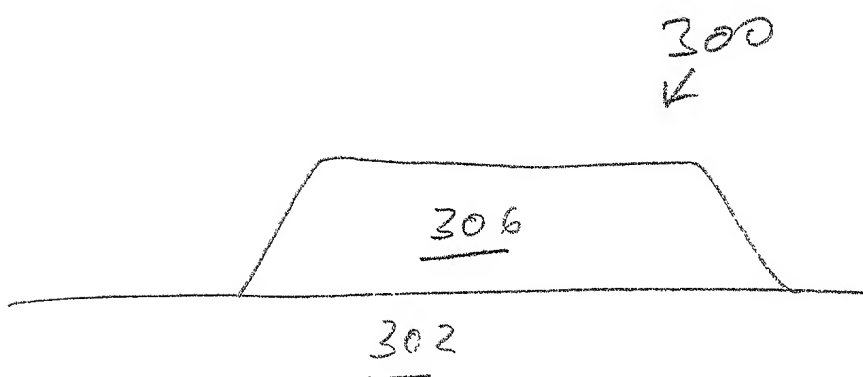


Fig. 36

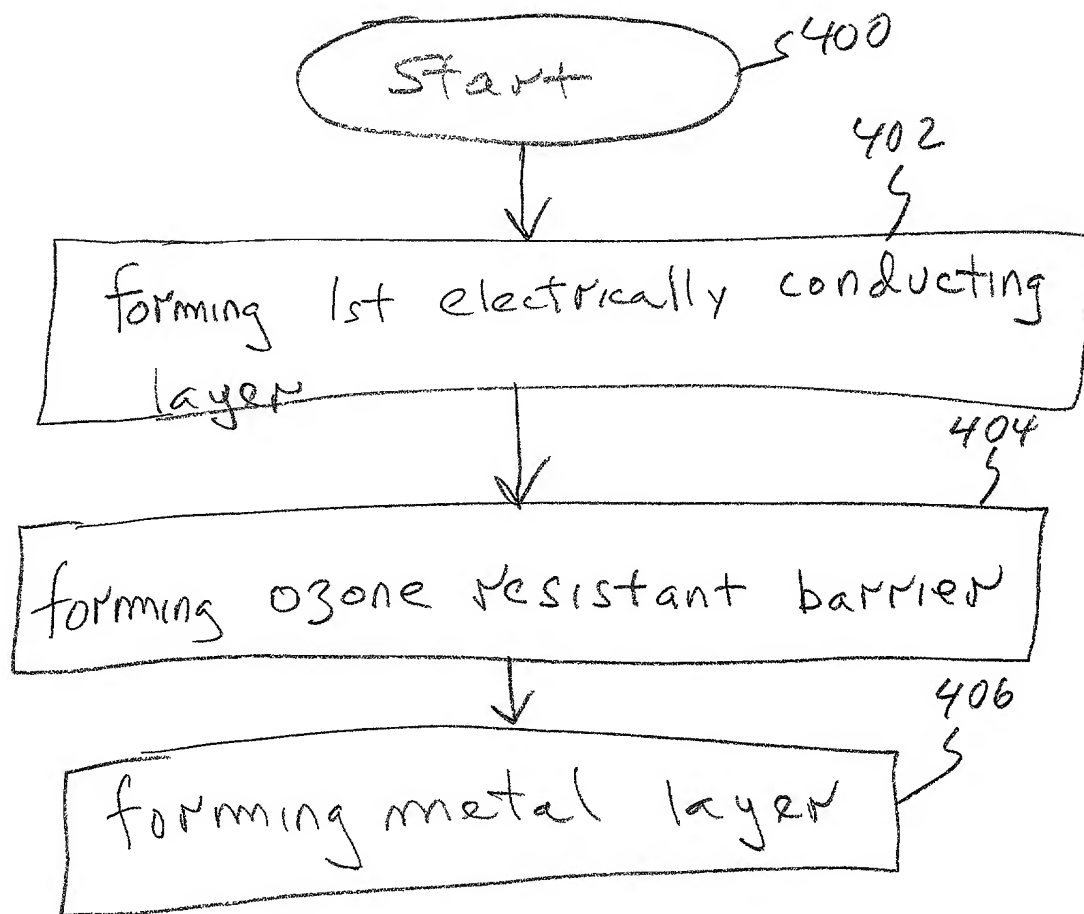


Fig. 4

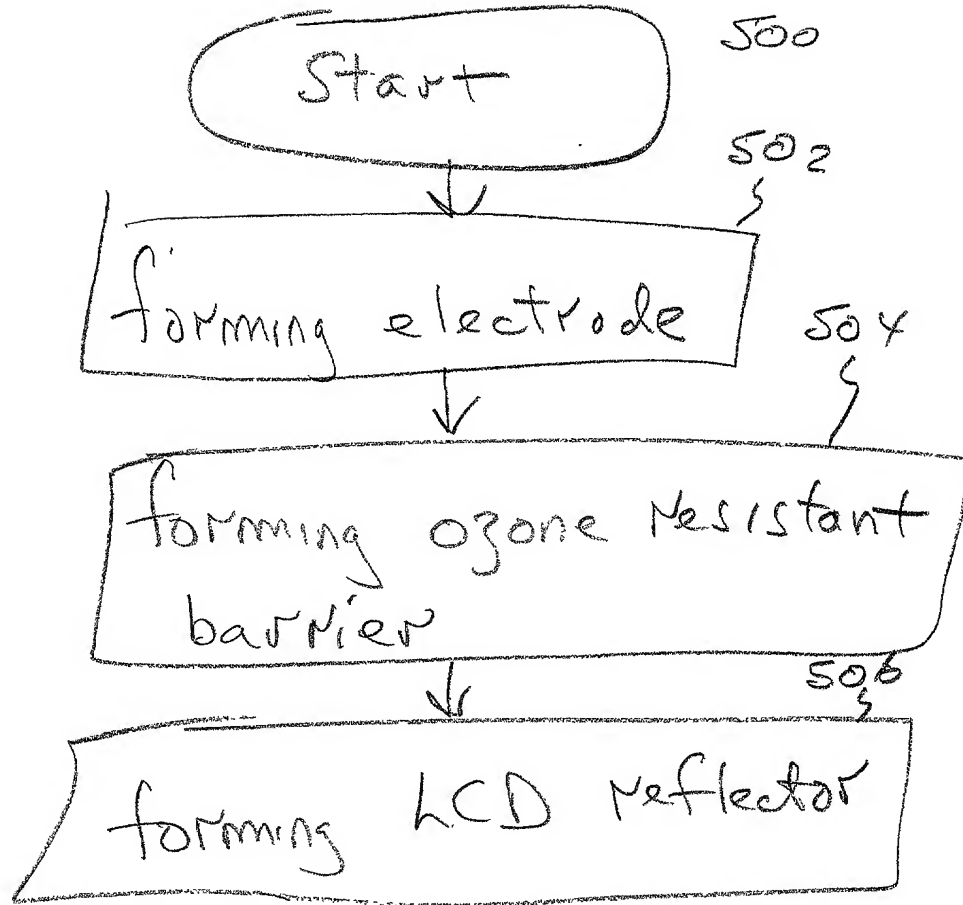


Fig. 5

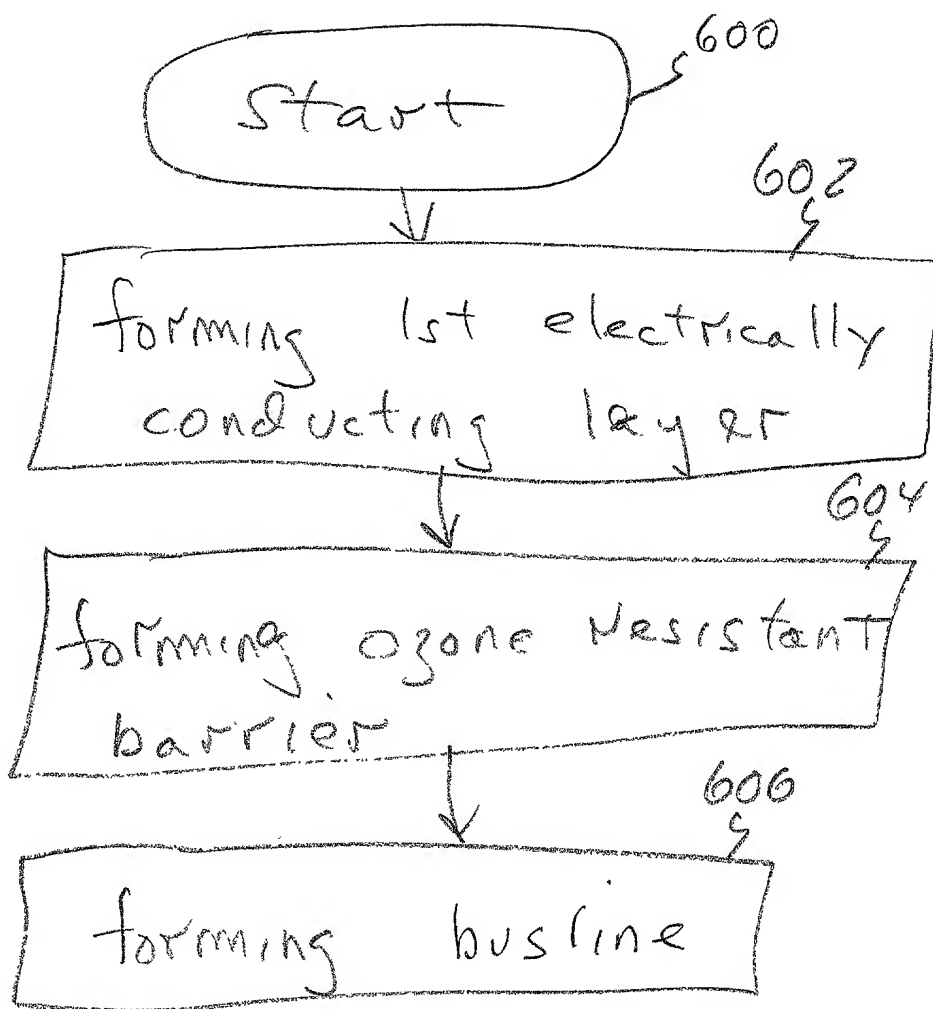


Fig. 6

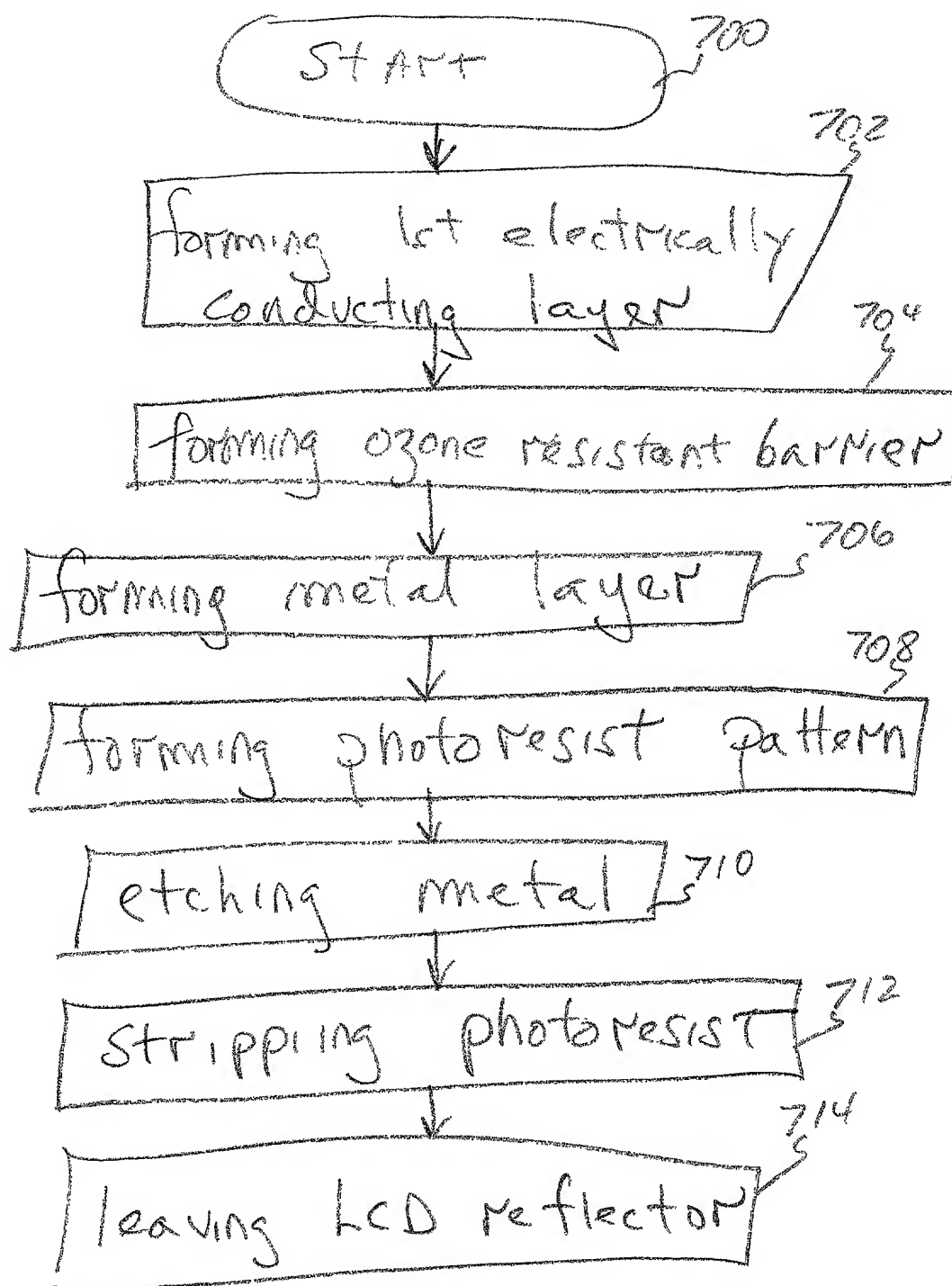


Fig. 7

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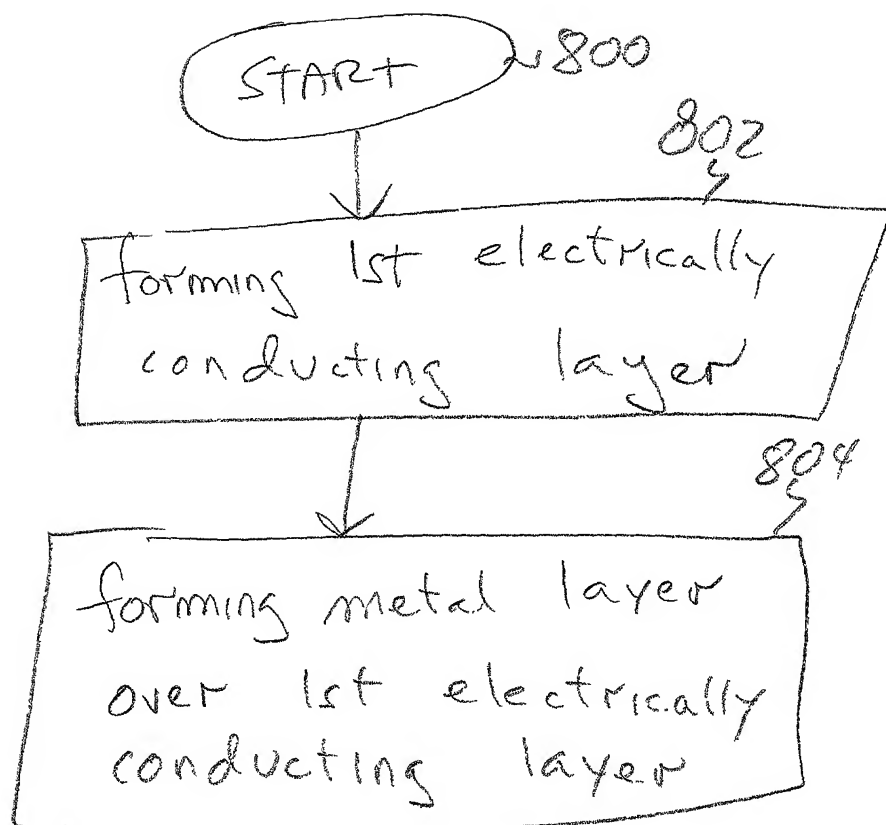


Fig. 8